



#11 AF/2800

PATENTS

4-11-03

Muulish

RECEIVED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: VON AMMON ET AL 9

SERIAL NO.: 09/813,240

EXAMINER: J. MONDT

APR 10 2003

FILED: MARCH 20, 2001

GROUP: 2826

TECHNOLOGY CENTER 2800

TITLE: SEMICONDUCTOR WAFER MADE FROM SILICON AND
METHOD FOR PRODUCING THE SEMICONDUCTOR WAFERSPETITION UNDER RULE 136(a) AND RULE 17(a)(1)

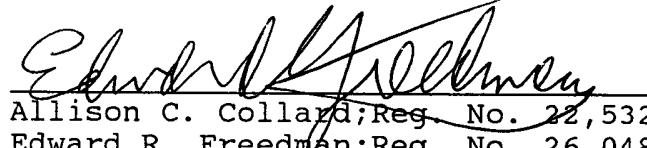
ATTN: BOX AFTER FINAL
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicant petitions the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated DECEMBER 12, 2002, for one month from MARCH 12, 2003, to APRIL 12, 2003. A check in the amount of \$110.00, covering the fee for a one-month extension for a Large Entity is enclosed herewith. Any deficiency or overpayment should be charged or credited to deposit Account No. 03-2468.

Respectfully submitted,


Allison C. Collard; Reg. No. 22,532

Edward R. Freedman; Reg. No. 26,048

Frederick J. Dorchak; Reg. No. 29,298
Attorneys for Applicants

COLLARD & ROE, P.C.
1077 Northern Boulevard
Roslyn, New York 11576
(516) 365-9802

Enclosure: Check in the amount of \$110.00

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Assistant Commissioner of Patents and Trademarks, Washington, D.C. 20231, on April 3, 2003


Maria Guastella